

Notice of References Cited	Application/Control No. 10/649,581	Applicant(s)/Patent Under Reexamination HAGIWARA, TAKESHI	
	Examiner Julie-Huyen L. Ngo	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,717,475	02-1998	Kamio et al.	349/147
	B	US-6,052,169	04-2000	Kim, Byung-hee	349/148
	C	US-6,133,978	10-2000	Tajima, Naoyuki	349/150
	D	US-6,665,037	12-2003	Hagiwara, Takeshi	349/148
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 61059425 A	03-1986	Japan	HAYAKAWA et al.	G02F 01/133
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.